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APPLICATION NO. FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/292,132 04/14/1999		SALMAN AKRAM	M122-1171	3104	
21567 7	7590 03/26/2003				
WELLS ST. JOHN ROBERTS GREGORY & MATKIN P.S. 601 W. FIRST AVENUE SUITE 1300			EXAMINER		
			MULPURI, SAVITRI		
SPOKANE, W	SPOKANE, WA 99201-3828		ART UNIT	PAPER NUMBER	
			2812		
			DATE MAII ED. 02/26/2002		

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary

Application No. 09/292,132

Applicant(s)

Akram et al

Examiner

Savitri Mulpuri

Art Unit 2812

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			4	Al		
ک اممالیما	The MAILING DATE of this communication appears of	n the cover sh	eet with	the correspondence address		
	or Reply Section Statistory Period For Reply IS SET T	O EXPIRE	3	MONTH(S) FROM		
THE N	A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.					
- Extensi	ons of time may be available under the provisions of 37 CFR 1.136 (a). In no	event, however, n	nay a reply b	pe timely filed after SIX (6) MONTHS from the		
If the n	date of this communication. eriod for reply specified above is less than thirty (30) days, a reply within the	statutory minimum	of thirty (3)	0) days will be considered timely.		
. Failure	eriod for reply is specified above, the maximum statutory period will apply and to reply within the set or extended period for reply will, by statute, cause the	application to become	me ABAND	ONED (35 U.S.C. § 133).		
- Any reg	oly received by the Office later than three months after the mailing date of this patent term adjustment. See 37 CFR 1.704(b).	s communication, e	ven if timely	filed, may reduce any		
Status	patent term adjustment. 366 37 G/H 1.754(d).					
1) 💢	Responsive to communication(s) filed on Jan 2, 200	3		·		
2a) 🗌	This action is FINAL . 2b) 🔀 This action	on is non-final				
3) 🗆	Since this application is in condition for allowance ex	cept for form	nal matte	ers, prosecution as to the merits is		
	closed in accordance with the practice under Ex part	te Quayle, 19	35 C.D.	11; 453 O.G. 213.		
	tion of Claims			to to a south of in the application		
	Claim(s) 51-53, 55-59, and 61-87					
4	a) Of the above, claim(s)		<u></u>	is/are withdrawn from consideration.		
5) 🗆	Claim(s)			is/are allowed.		
6) 💢	Claim(s) 51-53, 55-59, and 61-87			is/are rejected.		
7) 🗆	Claim(s)			is/are objected to.		
8) 🗆	Claims					
Applica	ition Papers					
9) 🗆	The specification is objected to by the Examiner.					
10)□	The drawing(s) filed on is/are	a) 🗌 accepte	ed or b)	Objected to by the Examiner.		
	Applicant may not request that any objection to the dr					
11)	The proposed drawing correction filed on	is	:: a)□	approved b) \square disapproved by the Examiner.		
11,	If approved, corrected drawings are required in reply to					
12)	The oath or declaration is objected to by the Examir					
Priority	under 35 U.S.C. §§ 119 and 120			,		
13)□	Acknowledgement is made of a claim for foreign pr	iority under 3	5 U.S.C	. § 119(a)-(d) or (f).		
	☐ All b)☐ Some* c)☐ None of:					
	1. Certified copies of the priority documents have	e been receiv	ed.			
	2. Certified copies of the priority documents have been received in Application No.					
	3. Copies of the certified copies of the priority do application from the International Bures	ocuments hav	e been r	received in this National Stage		
*S	see the attached detailed Office action for a list of the	e certified cop	oies not	received.		
14)	Acknowledgement is made of a claim for domestic	priority under	35 U.S	.C. § 119(e).		
a)[\square The translation of the foreign language provisiona	I application h	nas been	received.		
15)	Acknowledgement is made of a claim for domestic	priority under	r 35 U.S	.C. §§ 120 and/or 121.		
Attachn						
	otice of References Cited (PTO-892)	· 		TO-413) Paper No(s)		
3) 🗌 lr	formation Disclosure Statement(s) (PTO-1449) Paper No(s).	6) Uther:				

DETAILED ACTION

This action is in response to the applicant's amendment to the claims adding claims 84-87 and arguments filed on January 2/2003.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 51-53, 76-78, 82-83 are rejected under 35 U.S.C. 103(a) as being unpatentable over Suzuki et al or Oikawa (JP5-102067 from IDS)

Suzuki et al and Oikawa discloses a method of making a device by the following process steps. Providing a substrate, forming gate oxide layer and then annealing in any halogen elemental such as chlorine(Suzuki) injection technique by Oikawa and forming polysilicon gate electrode.

Both Suzuki et al and Oikawa do not disclose concentration of fluorine. Oikawa even disclose insitu doping of chlorine in gate oxide (see page

5, lines 1-12) in translation document).

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Neither Suzuki nor Oikawa doe not mention the concentration of the fluorine in the range of 1 X 10 ¹⁹ to 1 X 10²¹

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It would have been obvious to one of ordinary skill in the art to choose halogen element concentration in the oxide of the Suzuki or Oikawa depending on (1) the dose of the dopant for forming drain regions and there by dopant concentration at the interface drain and the substrate and (2)the voltage applied to the drain.(see for example florine in gate oxide in pan et al is 5 \times 10 20 /cm³

Normally, change in temperature, concentration, or both, is not patentable modification; however, such changes may impart patentability to process if ranges claimed produce new and unexpected result which is different in kind and not merely in degree from results of prior art; such ranges are termed "critical" ranges, and applicant has burden of proving such criticality; even though applicant's modification results in great improvement and utility over prior art, it may still not be patentable if modification was within capabilities of one skilled in art; more particularly, where general conditions of claim are disclosed in prior art, it is not inventive to discover optimum or workable ranges by routine experimentation. In re Aller et al,

105 U.S.P.Q. 233 CCPA (1955).

Claims 55-59, 68-75, 79, 81 62-67, 80 are rejected under 35 U.S.C. 103(a) as being unpatentable over Gardner et al.

Gardener et al disclose a method of making a FET device by the following process steps:

Providing a gate oxide layer on as surface of a substrate; forming a gate electrode on gate oxide layer, wherein side walls of the gate oxide and gate electrode are aligned; forming side walls spacers on the aligned side walls of the gate oxide and gate electrode, wherein side walls having fluorine either by doping or ion implantation; heat-treating the substrate with spacer in nitrogen ambient to suppress hot carrier effect (see col. 3-col. 5). Claim 68 is limited to "forming spacers with chlorine or fluorine only on lateral edge of the gate and not how spacers or formed with respect to gate oxide

After careful review, claims 62-27, 80 were interpreted on the disclosure of Gardner et al.

Gardner et al also discloses "forming sidewall spacers comprising at least one of chlorine and fluorine proximate the opposing edges and directionally over the gate oxide (see Gardner et al.). Gardener et al also discloses a forming spacers containing halogen element opposing edges of the gate and directly elevationally above over the gate oxide, when looked at lateral direction of the gate oxide.

Gardner et al do not disclose (1) concentration of the fluorine in the range of 1 X 10 ¹⁹ to 1 X 10²¹

/ cm ³ and concentration depth not more than 500 angstroms (3) forming gate oxide extending

laterally past the lateral edges of the gate.

It would have been obvious to one of ordinary skill in the art to choose halogen element concentration in the oxide depending on (1) the dose of the dopant for forming drain regions and there by dopant concentration at the interface drain and the substrate and (2)the voltage applied to the drain.

Normally, change in temperature, concentration, or both, is not patentable modification; however, such changes may impart patentability to process if ranges claimed produce new and unexpected result which is different in kind and not merely in degree from results of prior art; such ranges are termed "critical" ranges, and applicant has burden of proving such criticality; even though applicant's modification results in great improvement and utility over prior art, it may still not be patentable if modification was within capabilities of one skilled in art; more particularly, where general conditions of claim are disclosed in prior art, it is not inventive to discover optimum or workable ranges by routine experimentation. In re Aller et al, 105 U.S.P.Q. 233 CCPA (1955).

Applicant's arguments with respect to claims 51-53, 55-87 have been considered but are moot in view of the new ground(s) of rejection.

.Any inquiry concerning this communication or earlier communications from the examiner should be directed to S. Mulpuri whose telephone number is (703) 305-5184. The fax phone number for the organization where this application or proceeding is assigned is (703) 308-7722.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

SAVITRI MULPURI
PRIMARY EXAMINER